

# Body biasing fault injection: Enhancements, analysis, modeling, and simulation

## PhD thesis defense

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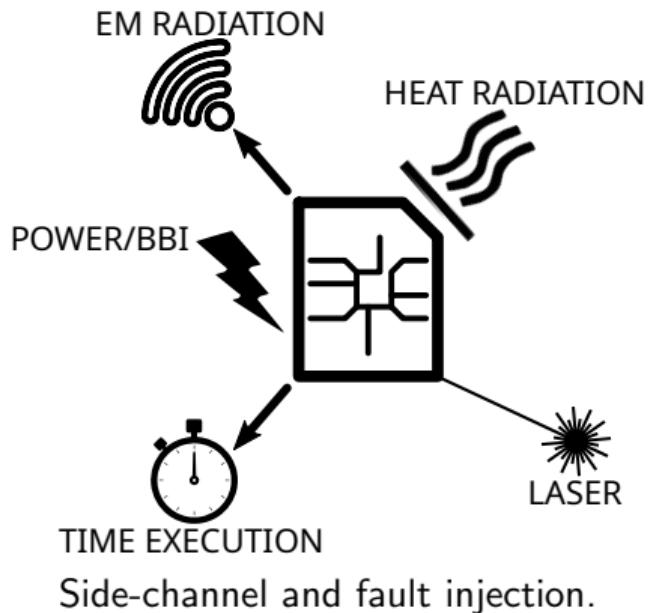
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# Context: hardware security

- Electronics are found in every economic sector
- In IoT, CPS, debit cards, phones, bank systems
- They embed cryptographic algorithms to ensure security
- These algorithms are fallible, they leak data and can be disturbed



# Fault injection attacks

Fault injection objectives:

- Denial of service (DoS) → Stop circuit operations and the related services
- Verification bypass → Modify data on the fly to fake authenticity
- Confidential data extraction → Modify data to perform differential fault analysis

Thanks to a fault injection platform:

- Power Glitch Fault Injection (PW-GFI)
- Clock Glitch Fault Injection (CK-GFI)
- Laser Fault Injection (LFI)
- Electromagnetic Fault Injection (EMFI)
- Body Biasing Fault Injection (BBI)

# Body biasing injection: state-of-the-art

"Yet another fault injection technique : by forward body biasing injection"	2011	Introducing the new technique and a Bellcore attack
"Voltage spikes on the substrate to obtain timing faults"	2012	Timing faults
"Body biasing injection attacks in practice"	2016	Lumped model for dual-well substrates
"Low-cost body biasing injection (BBI) attacks on WLCSP devices"	2020	Low-cost tool, fault analysis, hardware attack
"Breaking a Recent SoC's Hardware AES Accelerator Using Body Biasing Injection"	2022	Piret-Quisquater attack on hardware AES

# Body biasing injection: industrial and academic platforms

## Langer



### Current source:

- $4 \text{ A}$  in  $1 \Omega$
- $\pm 1 \text{ ns}$  jitter
- $2 \text{ ns}$  rise time

## Riscure



### Voltage source:

- Probe 64 A
- $450 \text{ V} \pm 45 \text{ V}$
- Max. PW 50 ns

## ChipSHOUTER



### Voltage source:

- 150 V to 450 V
- PW: 15 ns to 480 ns
- 220 ps jitter

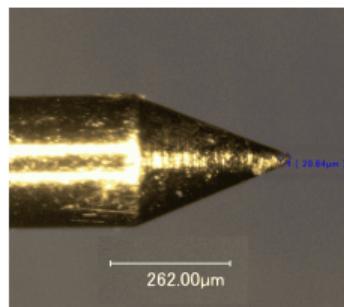
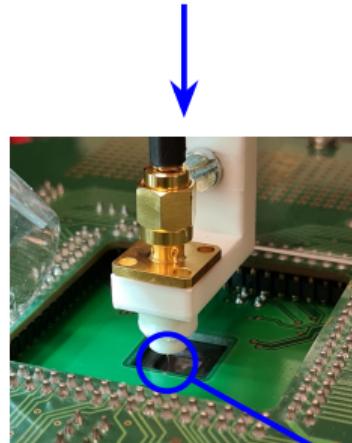
## Pico-EMP



### Voltage source (AC):

- Up to 250 V
- PW: 85 ns in  $50 \Omega$
- Up to 200 mW

# Body biasing injection: LIRMM BBI platform



## Main platform characteristics:

$V_{PULSE}$	[150 ; 750] V
$P_W$	[6 ; 20] ns
$T_R   T_F$	4 ns
Propagation delay	$[150 \cdot 10^{-9}; 1]$ s
Input jitter	$\pm 100 ps \pm 0.03\%$
Output coupling	DC
Gen. $I_{MAX}$ ( $50 \Omega$ )	16 A
Probe $\varnothing$	20 $\mu m$

# Thesis objectives

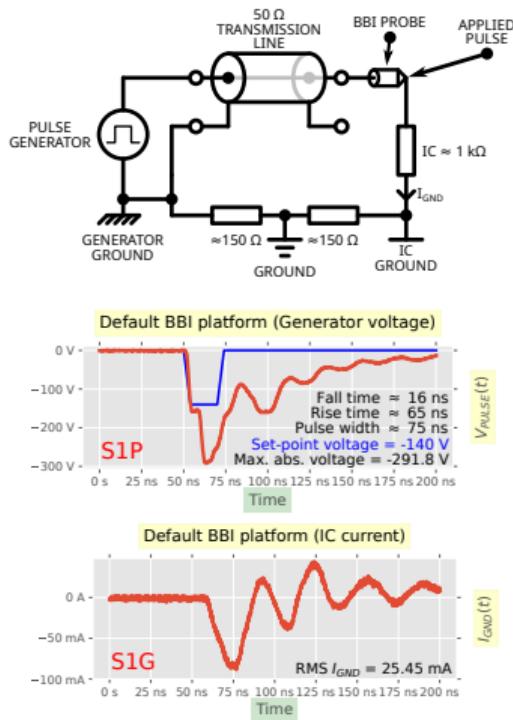
- What is the spatial resolution of BBI?
- What is the time resolution of BBI?
- Is thinning the substrate useful in any way?
- How BBI induced faults occur?
- How to model BBI?

# Thesis agenda

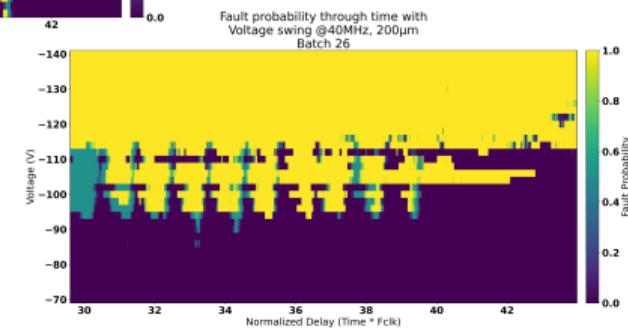
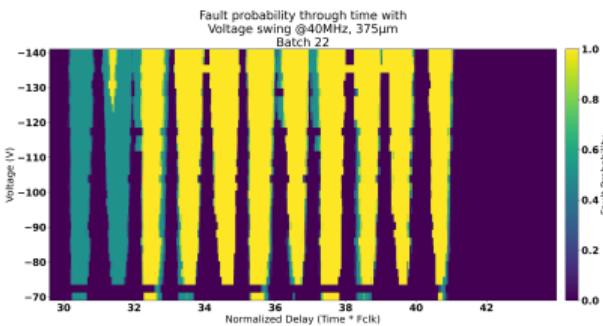
- Enhancing the practice of Body Biasing Injection
- Integrated circuits modeling for BBI
- Enhanced simulation flow
- Substrate thinning analysis in a BBI context
- Conclusion and perspectives

## BETTER PRACTICES FOR BODY BIASING INJECTION

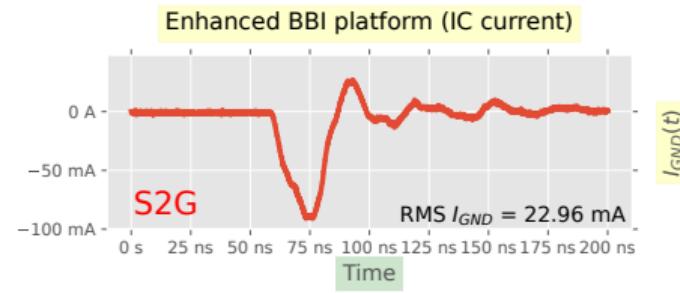
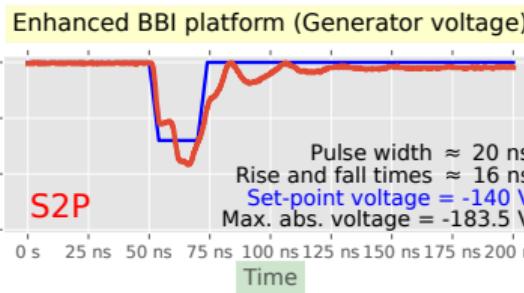
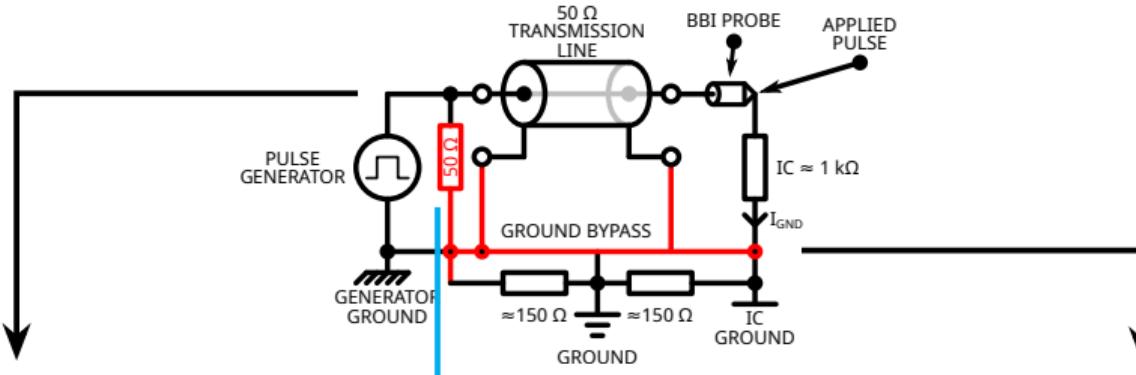
# State-of-the-art BBI platform: limiting factors



- Impedance mismatch → Ringing and set-point error
- Floating grounds → Set-point error



# Enhanced BBI platform

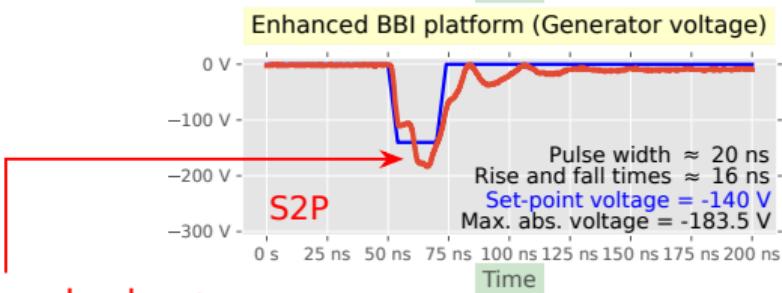
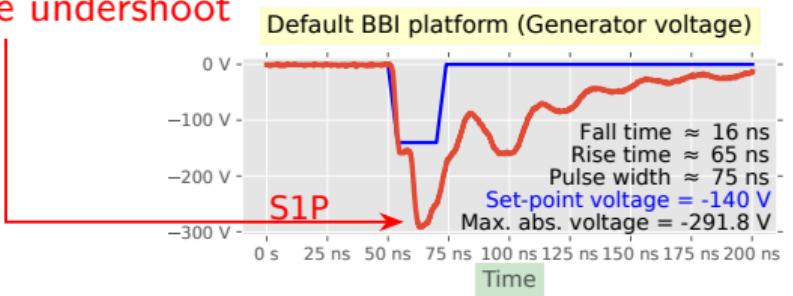


# Enhanced BBI platform

## Summary

275 % PW overshoot

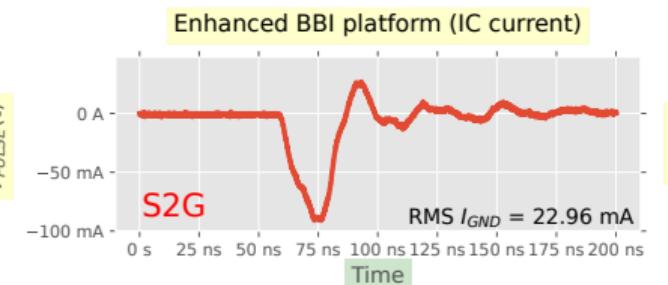
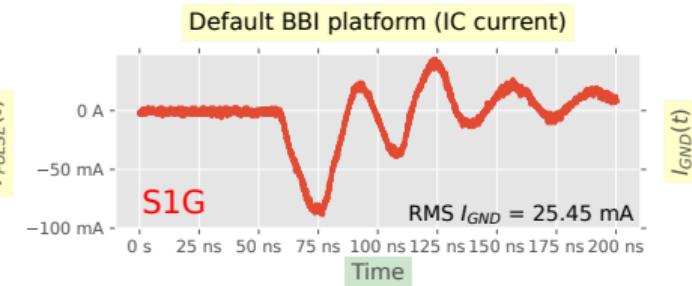
-108 % pulse undershoot



-31 % pulse undershoot

Matched pulse width

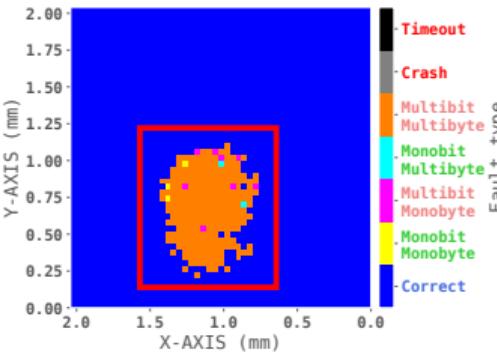
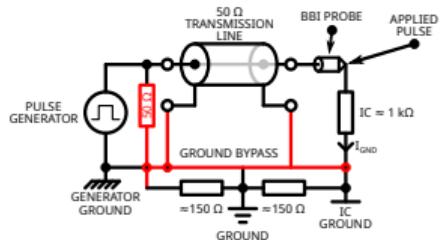
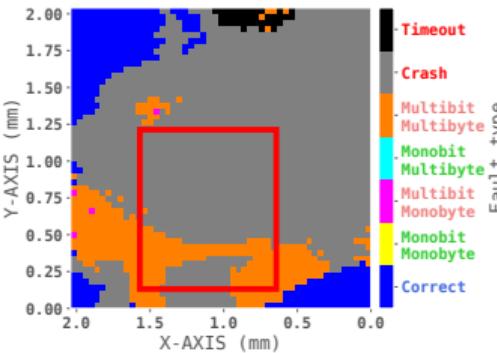
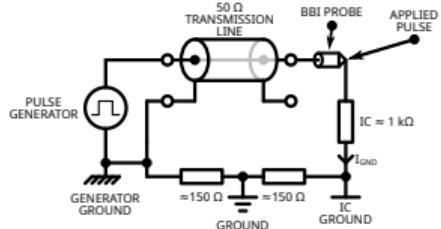
Ringing: more than 100 ns



Ringing: 15 ns

# Enhanced BBI platform benefits

## Giraud's single bit fault attack



Giraud's DFA → impossible No single bit faults  
2601 tested locations

5 locations → single bit faults  
14 secret-key bytes out of 16  
2 remaining bytes → brute force

# MODELING AND SIMULATING BODY BIASING INJECTION

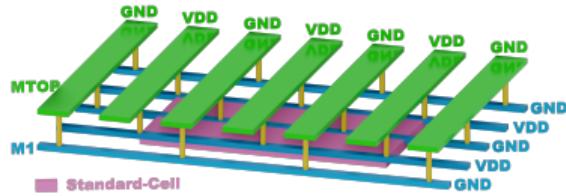
# Why modeling and simulating BBI?

Observe the signals inside the IC:

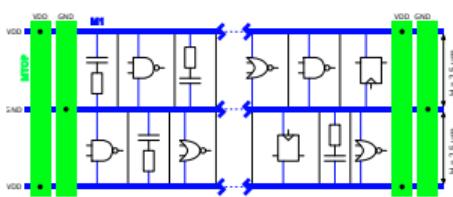
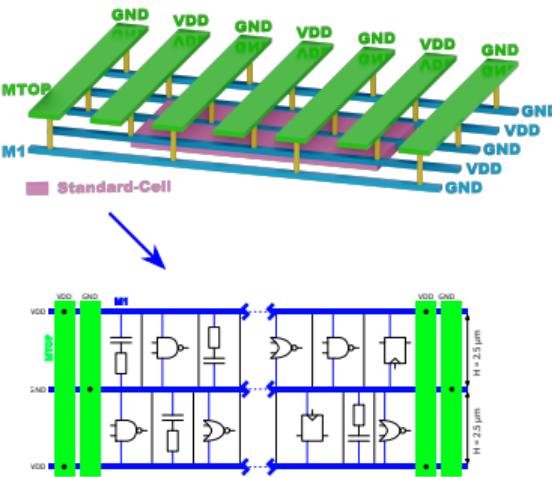
- Embedded sensors → costly and long to implement
- Will be disturbed by the voltage pulses

Therefore: simulation → conclusions → verification

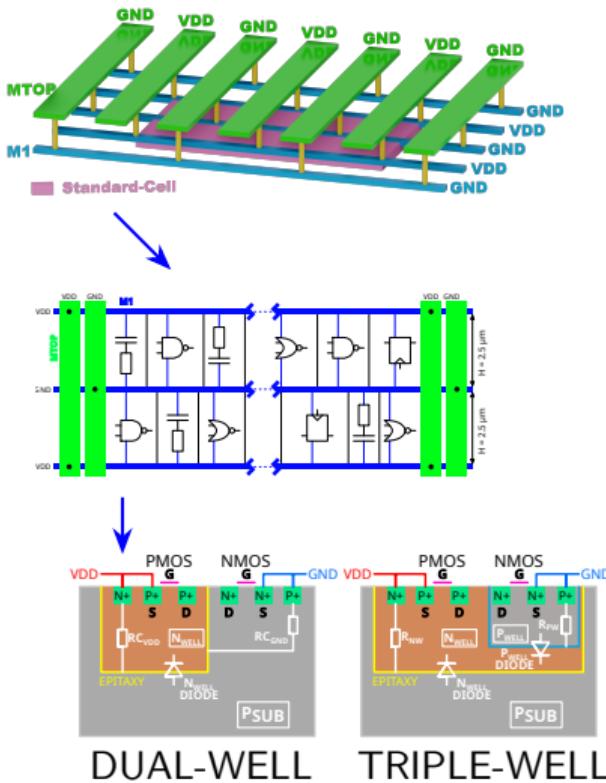
# Simulation models



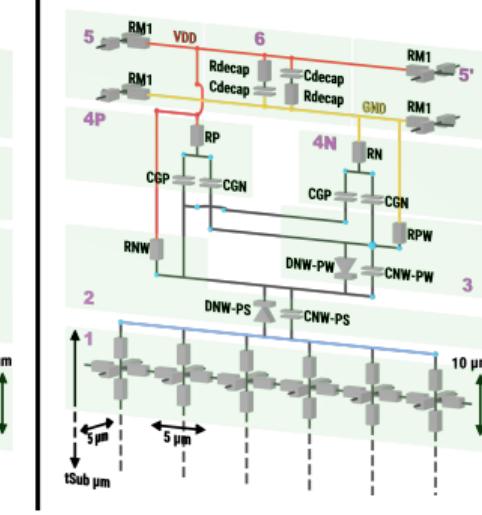
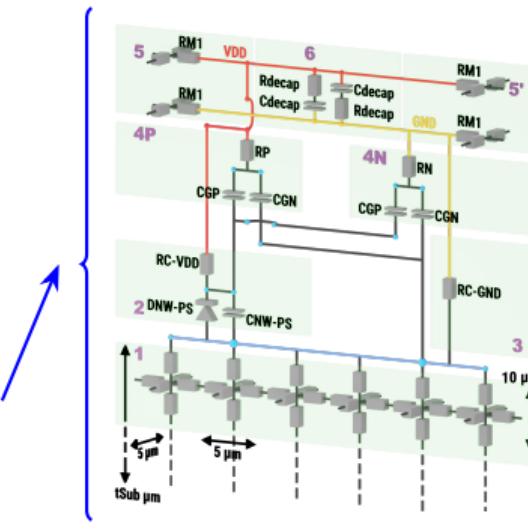
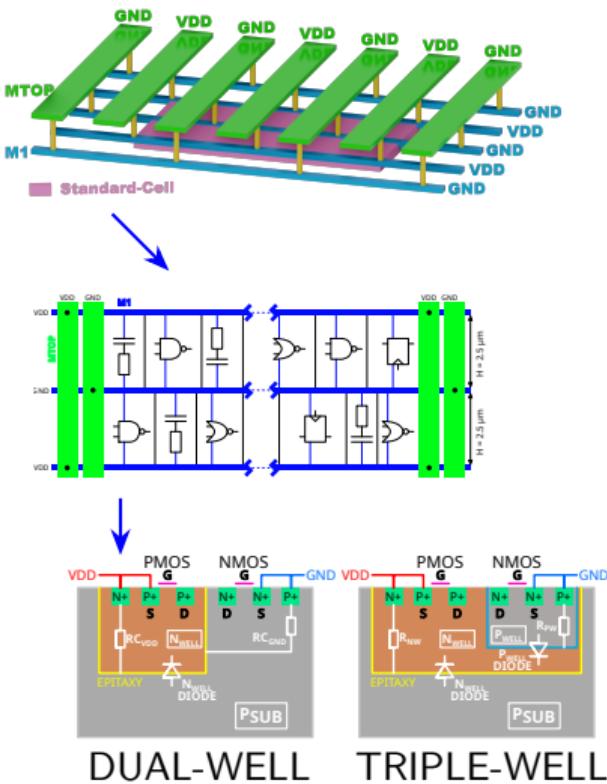
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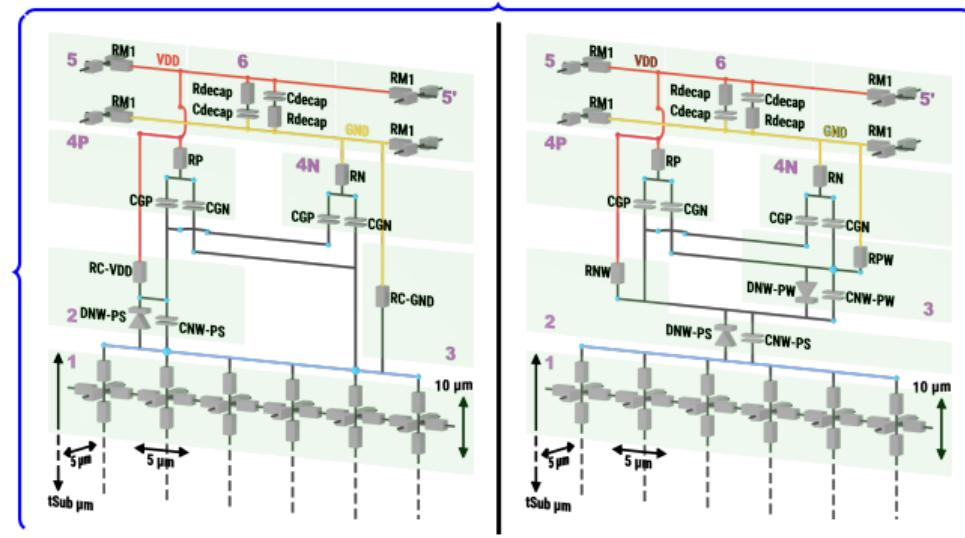
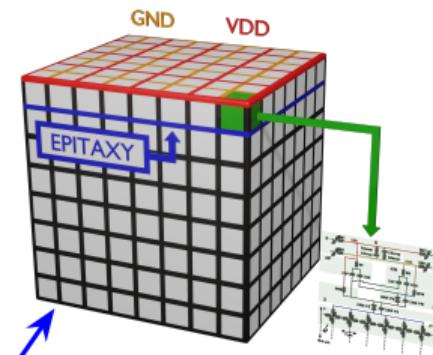
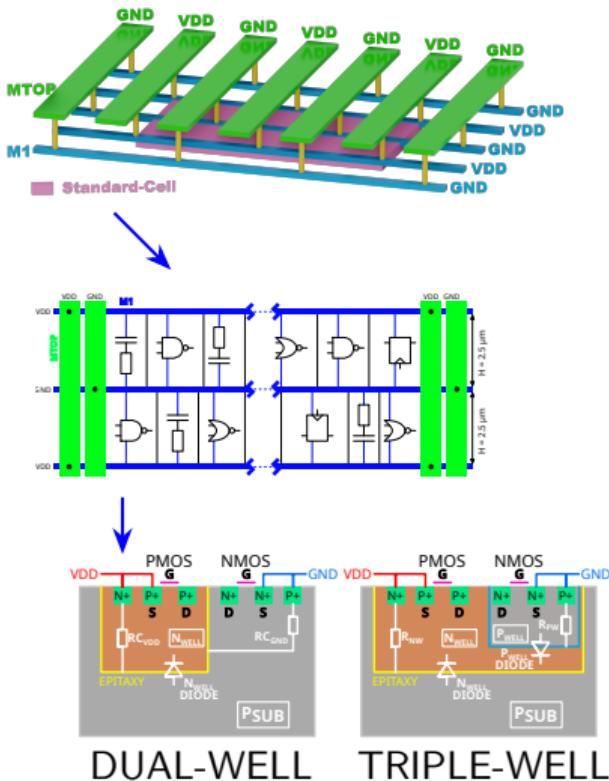
## Simulation models



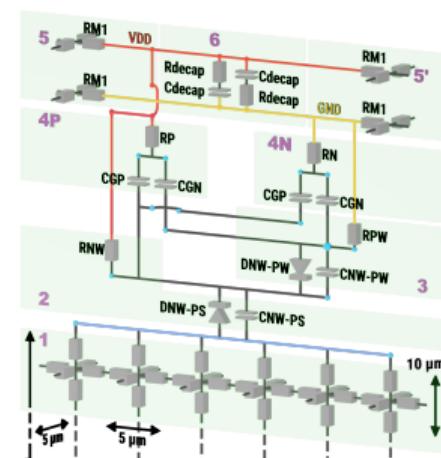
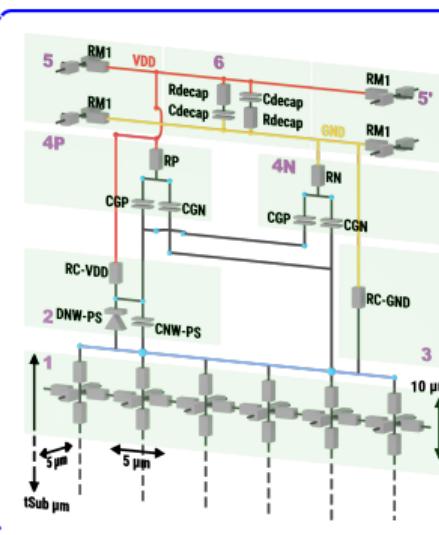
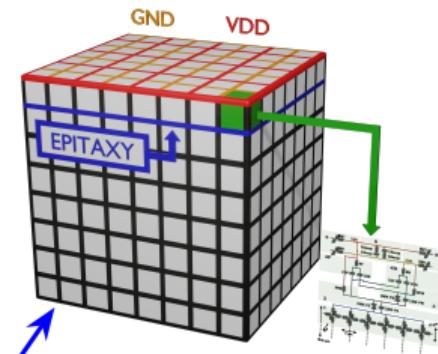
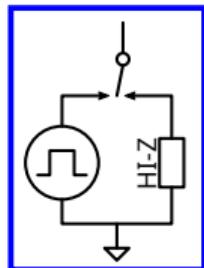
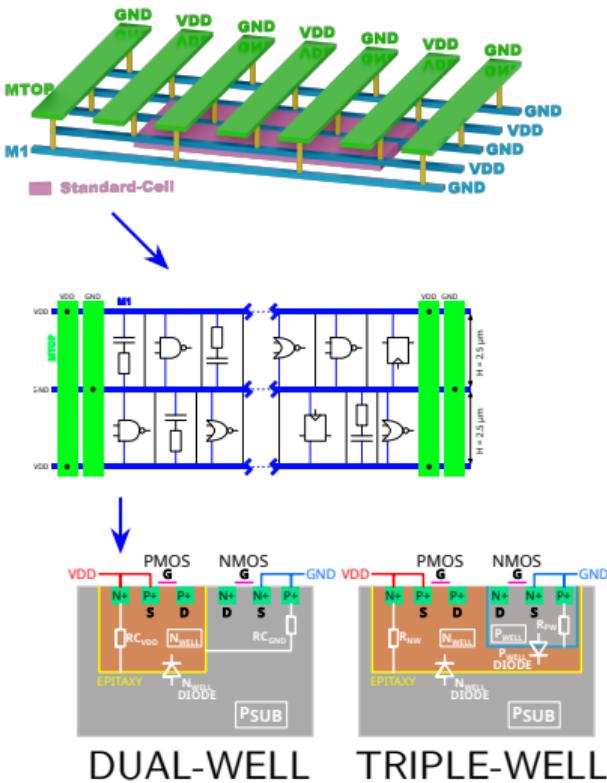
## Simulation models



## Simulation models



## Simulation models



# Simulation results

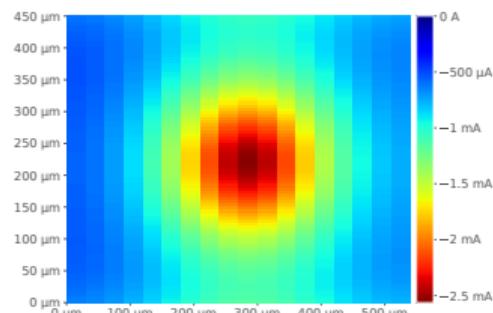
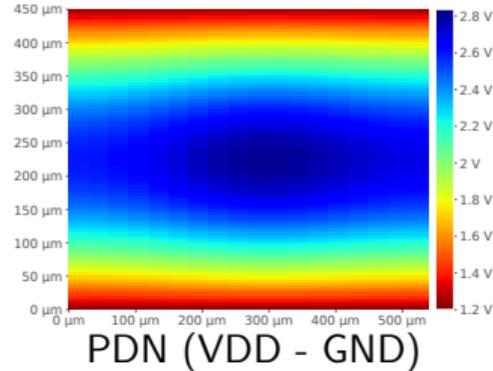
What we observe:

- Dual-well
- Triple-well
- Picture at the apex of the pulse
- $550 \mu m (W) \times 450 \mu m (D) \times 140 \mu m (T)$ : integrated circuit  $\rightarrow$  1620 SCS
- 90 nm Bulk CMOS

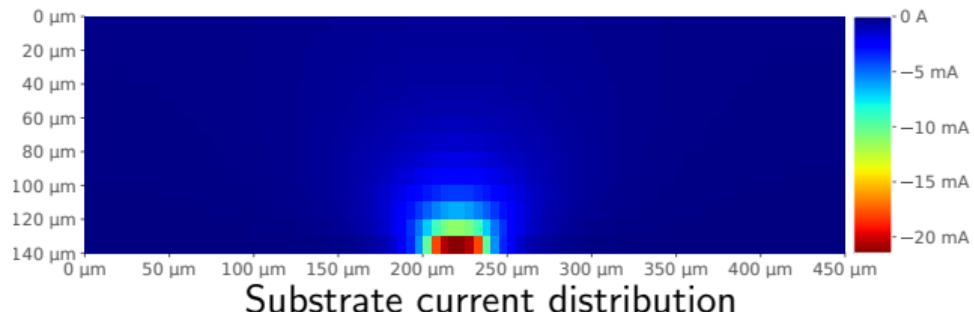
Simulation conditions:

- Voltage pulse amplitude: -300 V
- Voltage pulse width: 20 ns
- Rise and fall times: 8 ns
- Approximate impedance matching

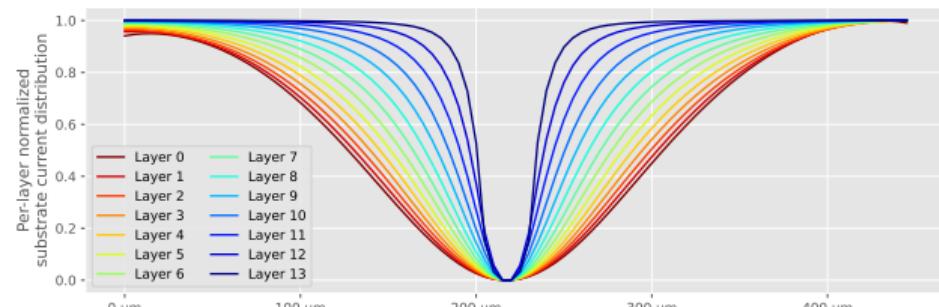
# Simulation results: Dual-Well



Epitaxy current distribution



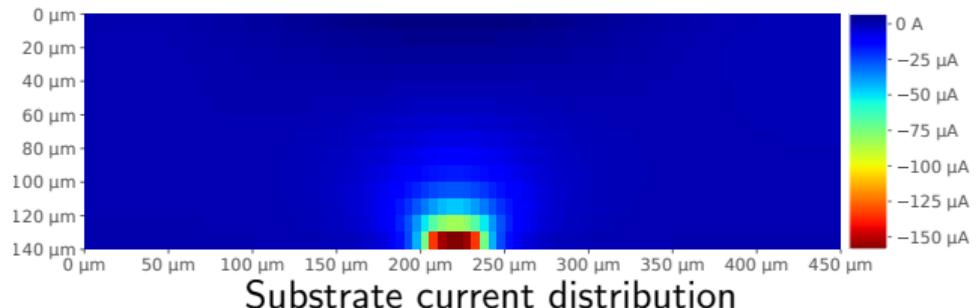
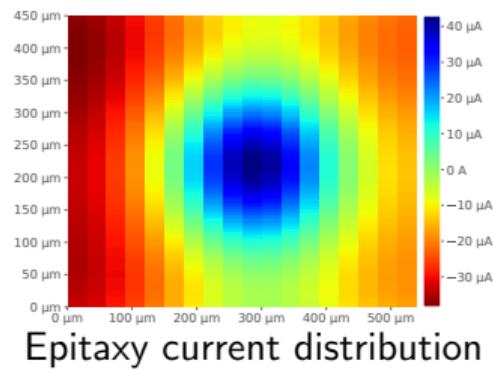
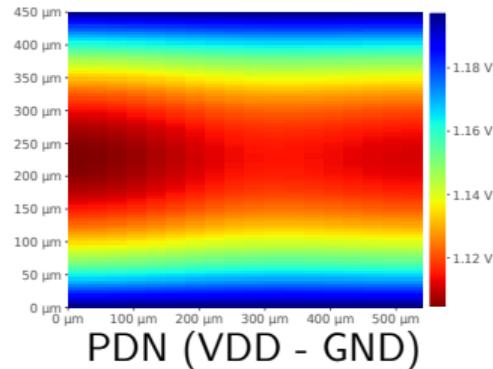
Substrate current distribution



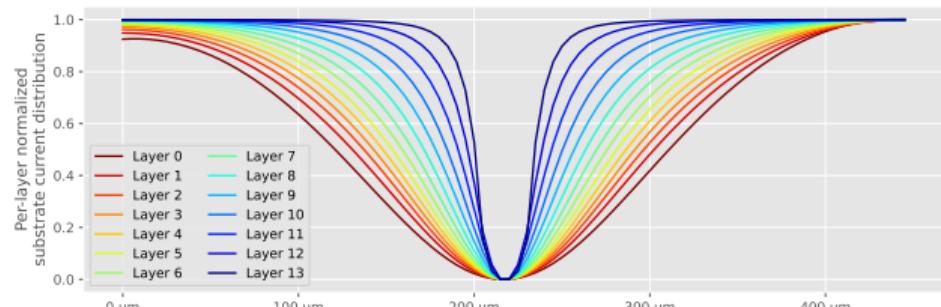
Per-layer normalized substrate current density

180 μm diameter mid-height

# Simulation results: Triple-Well



Substrate current distribution



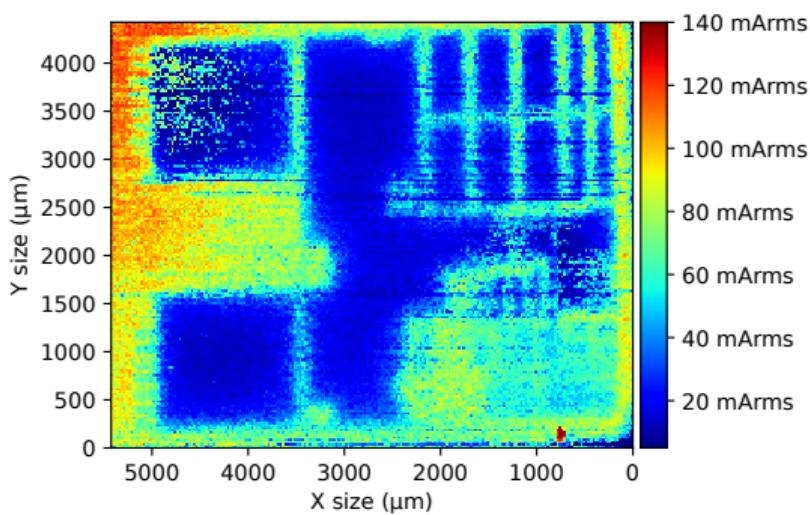
Per-layer normalized substrate current density:  
186 μm diameter mid-height

# Dual-well vs Triple-well

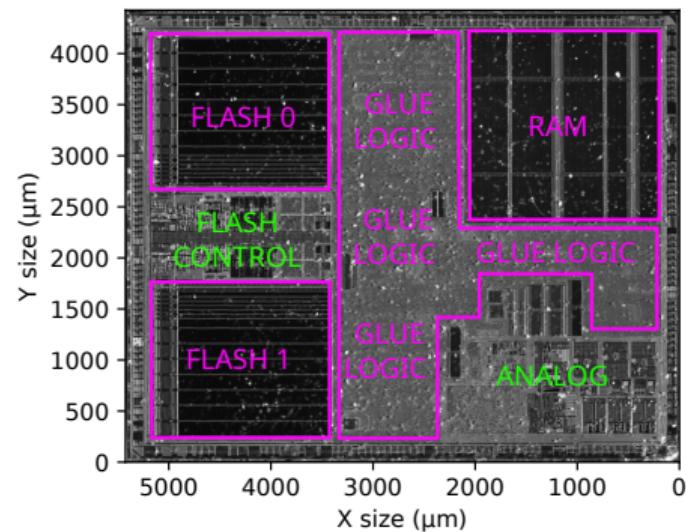
**Differences between Dual-well and Triple-well circuits:**

Substrate	Polarity	Coupling			Danger
		NMOS	PMOS	Circuit	
Dual-well	Negative	DC	AC	DC	+++
Dual-well	Positive	DC	DC	DC	++++
Triple-well	Negative	AC	AC	AC	+
Triple-well	Positive	AC	DC	DC	+++

# Simulation results verification

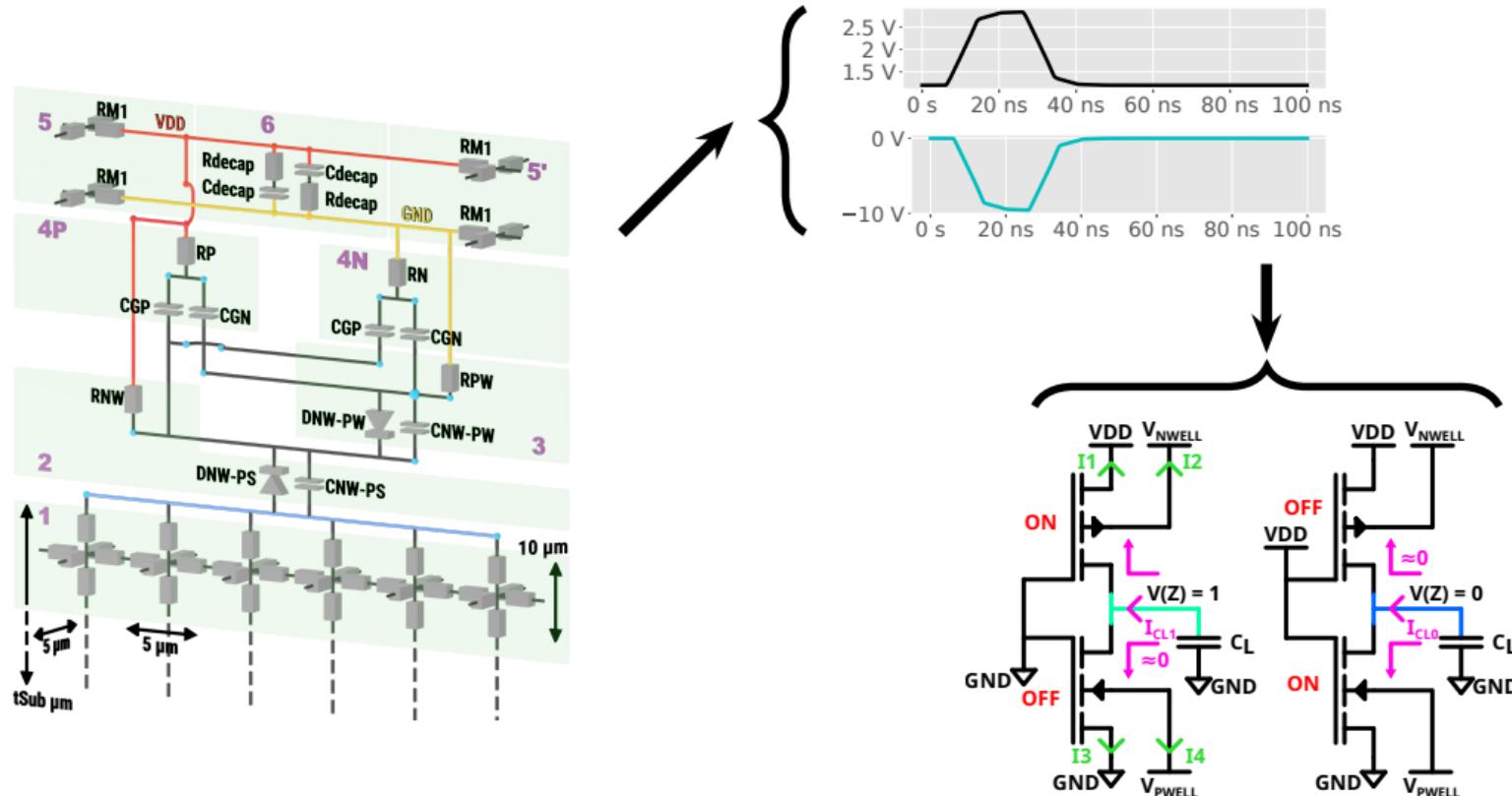


$V_{PULSE} = -70 \text{ V}; PW = 20 \text{ ns}$



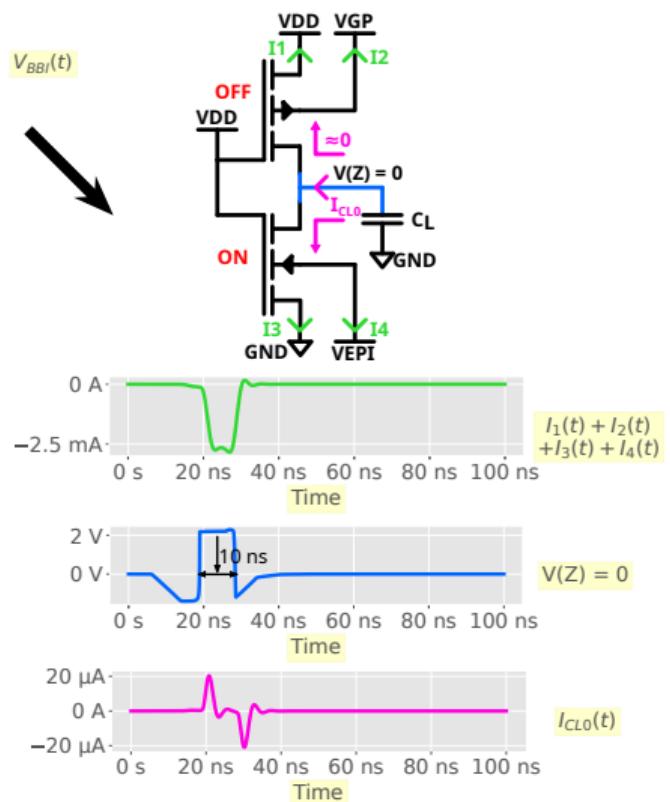
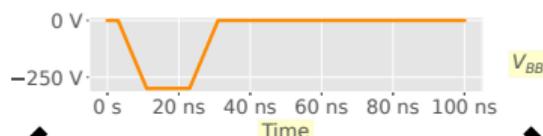
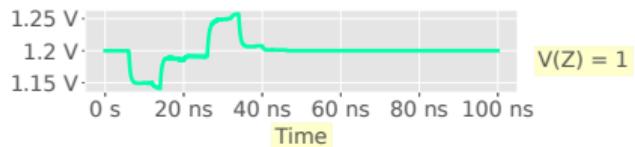
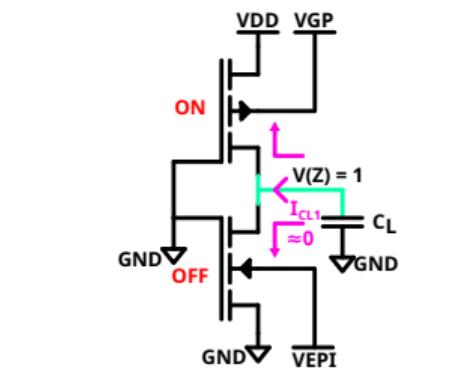
## SIMULATION FLOW FOLLOW-UP: HOW FAULTS OCCUR?

# SCS incomplete models: how to consider logic function?



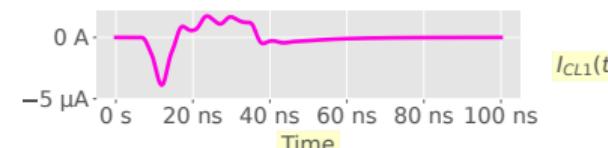
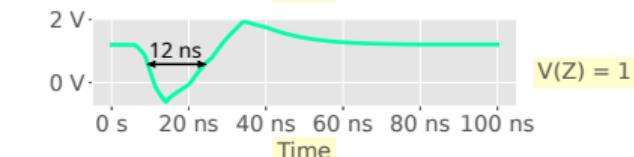
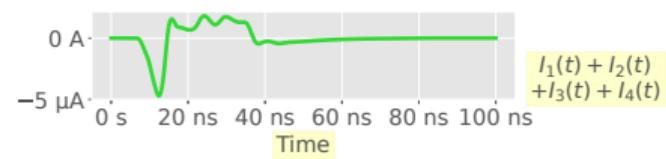
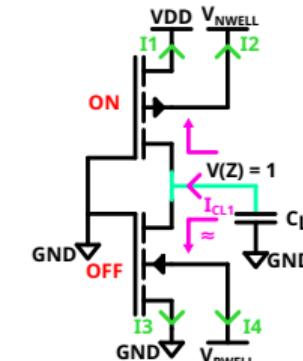
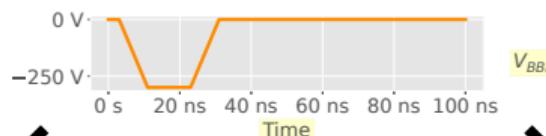
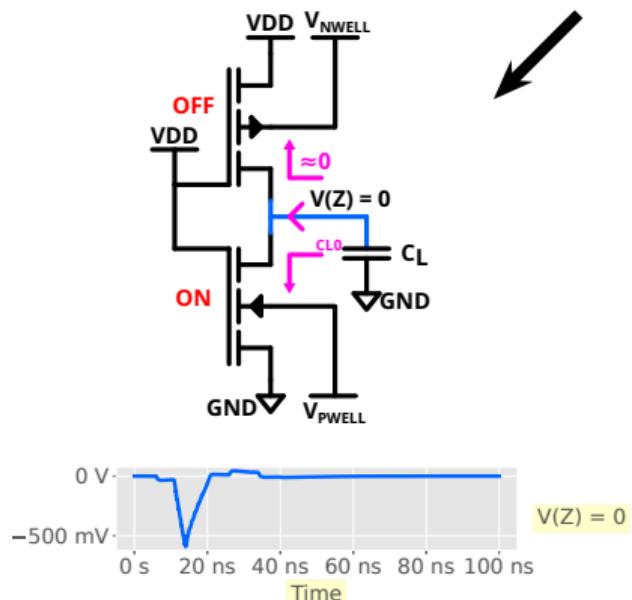
# How faults occur under BBI?

Dual-well inverters



## How faults occur under BBI?

## Triple-well inverters



## How faults occur under BBI?

### Fault model

BBI injects or absorbs charges from the probe up to the power delivery network

The resulting current charges or discharges the logic gates output

**BBI is an electron vacuum cleaner**

Data dependent faults → can BBI be used to perform safe-error attack?

# SUBSTRATE THINNING ANALYSIS

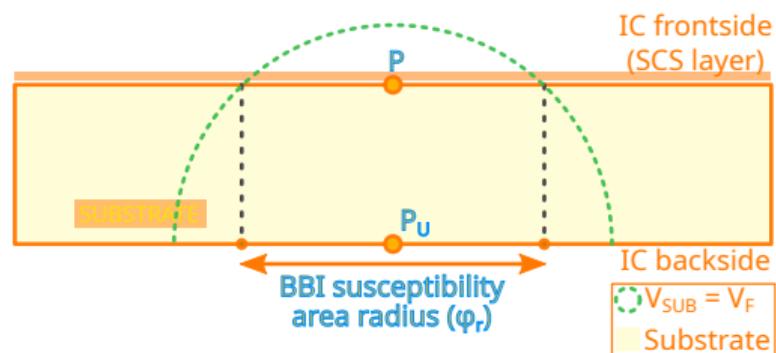
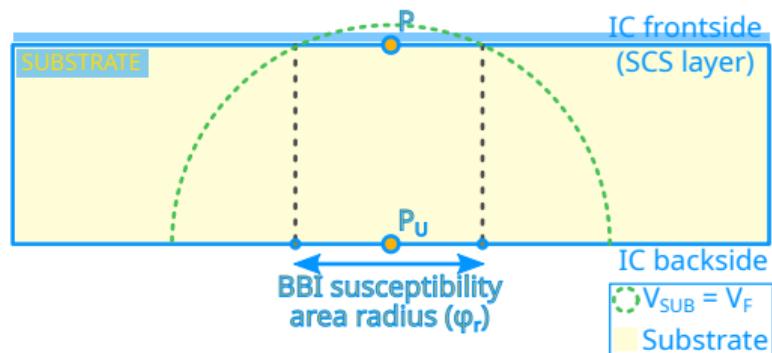
# Substrate thinning in a BBI context

In Laser Fault Injection, substrate thinning has been proven useful  
Is it the case concerning BBI?

Section agenda:

- Geometric approach
- Electrical simulation approach
- Experimental validation

# Geometric approach

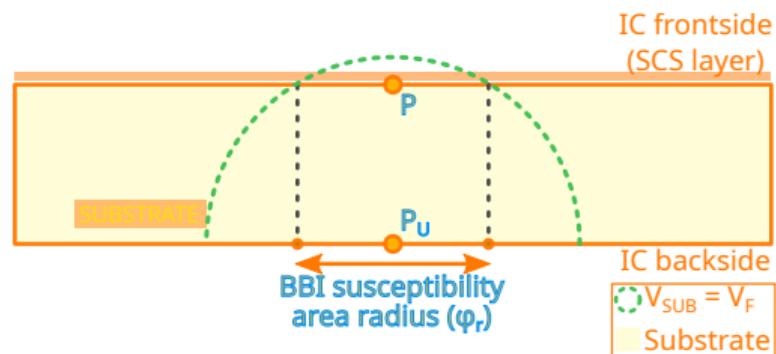
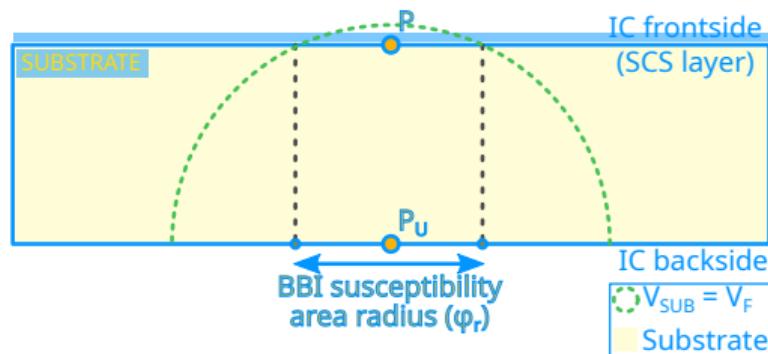


$$\phi_r(t) = 2 \cdot \sqrt{r(t)^2 - t_{SUB}^2} \quad (1)$$

$$\frac{\phi_r^{THIN}}{\phi_r^{THICK}} = \sqrt{\frac{r^2 - t_{THIN}^2}{r^2 - t_{THICK}^2}} > 1 \quad (2)$$

Higher susceptibility area  $\rightarrow$  greater current density

# Geometric approach



$$V_{PU}^* = \frac{t_{THIN}}{t_{THICK}} \cdot V_{PU} + V_F \cdot \left(1 - \frac{t_{THIN}}{t_{THICK}}\right) \quad (3)$$

## Geometric approach outcomes

- Thinning the substrate → Reduce the voltage pulse for a given susceptibility area
- Thinning the substrate → Susceptibility area increases at constant voltage
- Thinning the substrate → No improvement in resolution

# Simulation approach

What we observe:

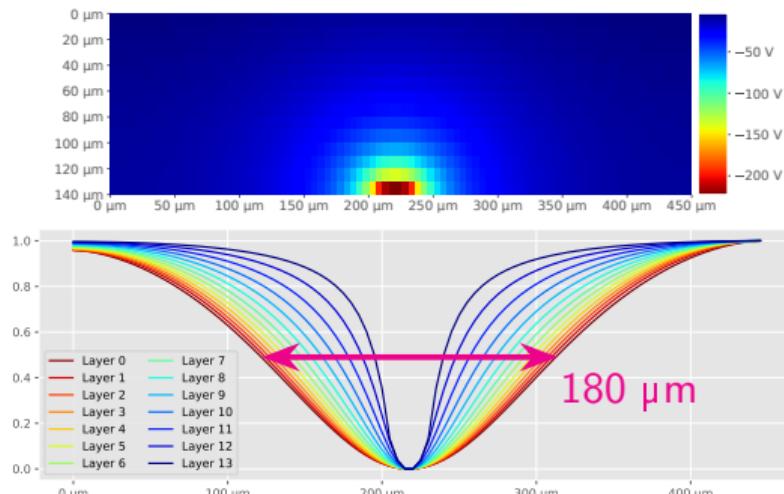
- Dual-well substrate IC
- Picture at the apex of the pulse
- $550 \mu\text{m} (W) \times 450 \mu\text{m} (D)$ : integrated circuit  $\rightarrow 1620$  SCS
- $140 \mu\text{m} (T)$  IC
- $60 \mu\text{m} (T)$  IC

Simulation conditions:

- Voltage pulse amplitude: -300 V
- Voltage pulse width: 20 ns
- Rise and fall times: 8 ns

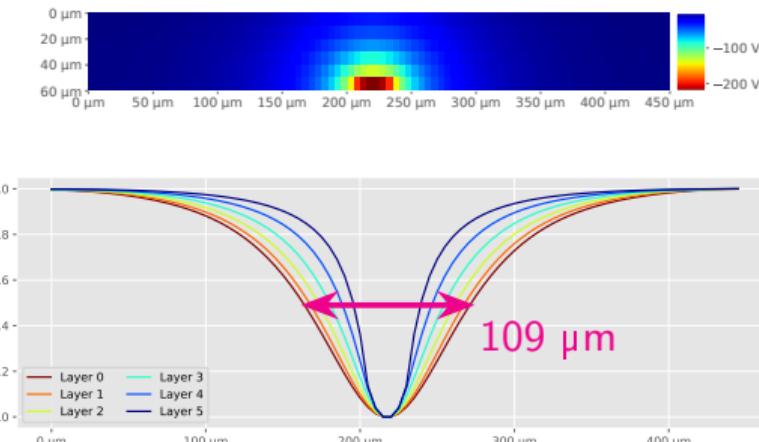
# Simulation approach

Substrate voltage distribution (140  $\mu\text{m}$ )



Substrate normalized current density (140  $\mu\text{m}$ )  
Highest layer @ 0.5 density diameter: 180  $\mu\text{m}$

Substrate voltage distribution (60  $\mu\text{m}$ )



Substrate normalized current density (60  $\mu\text{m}$ )  
Highest layer @ 0.5 density diameter: 109  $\mu\text{m}$

**For half of the normalized density  $\rightarrow$  lower diameter  $\rightarrow$  greater current density**

## Substrate thinning in practice

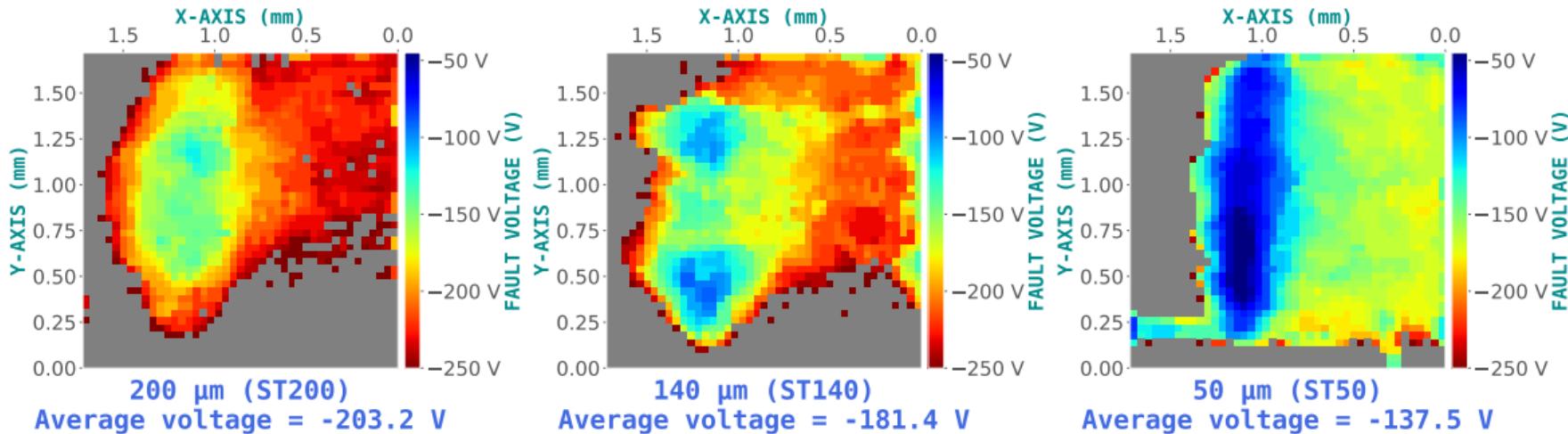
Three experiments to verify the soundness of the outcomes:

- Fault susceptibility maps
- Susceptibility area spreading maps
- Susceptibility area comparison

# Substrate thinning in practice

## Fault susceptibility maps

200  $\mu\text{m}$ , 140  $\mu\text{m}$  and 50  $\mu\text{m}$  FSM

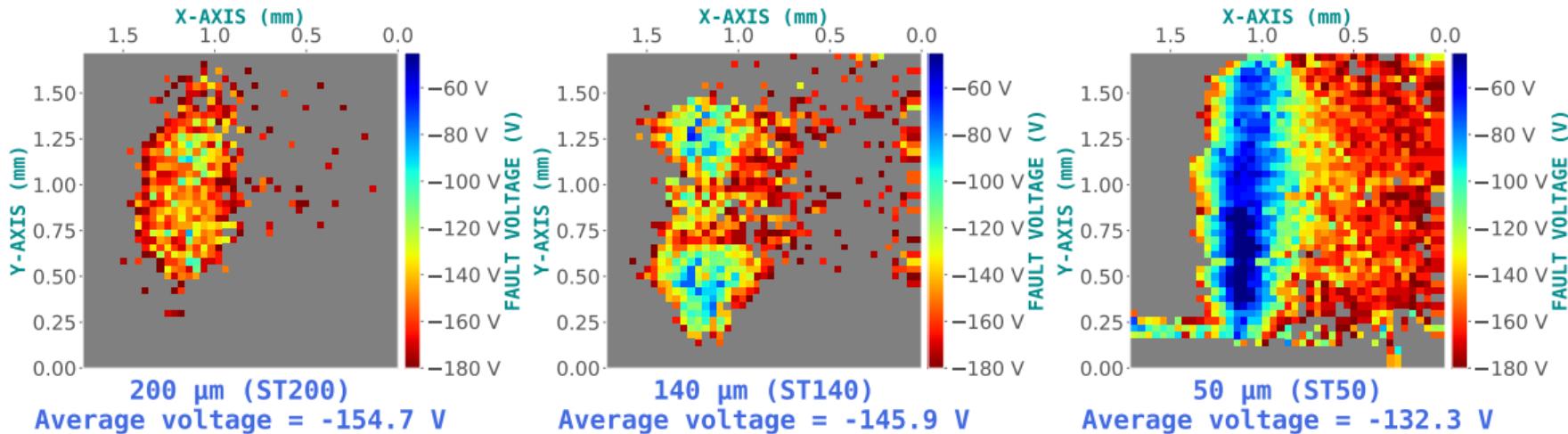


Thinning the substrate → reduces the voltage required to induce faults

# Substrate thinning in practice

Susceptibility area spreading

200  $\mu\text{m}$ , 140  $\mu\text{m}$  and 50  $\mu\text{m}$  FSM

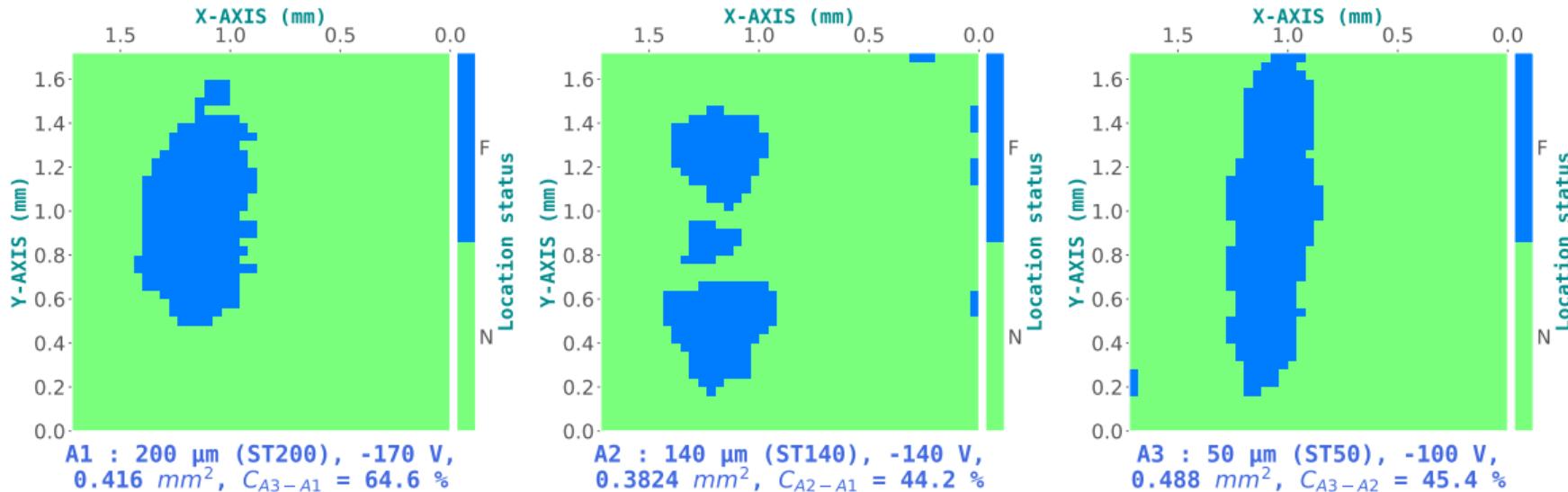


Thinning the substrate → increases the susceptibility for a given maximum voltage

# Substrate thinning in practice

## Fault susceptibility maps areas comparison

200  $\mu\text{m}$ , 140  $\mu\text{m}$  and 50  $\mu\text{m}$  susceptibility areas comparison (F = FAULT, N = NO FAULT)



Same susceptibility areas with correct couple: ( $V_P, t_{SUB}$ )  
No change in spatial resolution

## CONCLUSION AND OUTLOOKS

# Conclusion

- Better practices for BBI → successful DFA:
  - Impedance matching
  - Low impedance grounding
- Modeling and simulating BBI:
  - Local effect on ICs → [100, 200] μm
  - Thanks to a DC or AC coupling with the probe
  - Data-dependent faults (bit set and bit reset)
  - DW substrate / TW positive → dangerous
- Substrate thinning and BBI:
  - Lowers generator power requirements
  - Does not change spatial resolution → depends on ( $V_P$ ,  $t_{SUB}$ )

# Outlooks

## Further improvements:

- Adaptive impedance matching → increase repeatability
- Further study logic gates disturbance study → dynamic analysis
- Study memory elements and analog blocks (SRAM, FLASH, PLL)